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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Seidl, et al. Attorney Docket: INF-130
Filed: January 28, 2004 Examiner: TBD
Serial No.: 10/765,052 Art Unit: 2812
For: Method of Fabricating an Oxide Collar for a Trench Capacitor

Mail Stop: Amendment
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Respectfully submitted,

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October 14, 2004

Date

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Date of Deposit: October 14, 2004

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Information Disclosure Statement (1 page)
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Copies of (3) cited references
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Respectfully submitted,

Natalie Swider
Legal Assistant

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PTO/SB/08a (08-03)

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Complete if Known

Application Number	10/765,052
Filing Date	1/28/2004
First Named Inventor	Seidl, et al.
Art Unit	2812
Examiner Name	TBD
Attorney Docket Number	INF-130

Sheet	1	of	1
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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
	1	US-6,777,303 B2	08-17-2004	Schrems, et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
	2	DE 199 56 078 A1	05-31-2001	Infineon Technologies AG		

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	3	KLAUS, J.W., et al., "Atomic Layer Deposition of SiO ₂ Using Catalyzed and Uncatalyzed Self-Limiting Surface Reactions," Surface Review and Letters, Vol. 6, Nos. 3 & 4 (1999) pp. 435-448.	
	4	KLAUS, J.W., et al., "Growth of SiO ₂ at Room Temperature with the Use of Catalyzed Sequential Half-Reactions," Department of Chemistry and Biochemistry, University of Colorado, Boulder, CO (1997).	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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